

# Yuan Yao

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## Education

- **Jilin University, China** 2021.9-now  
*Bachelor of Engineering, School of mechanical and aerospace engineering* Overall score: 90.62/100, rank within top 5%
- **Tohoku University, Japan** 2023.10-2024.8  
*Exchange student, Department of Robotics* 8/9 Course grades: A/ AA

## Research experiences

- **Exploration of Film Separation Technique by Internal Laser Damage** 2023.10-2024.8  
*Exchange student advised by Prof. Shuji Tanaka and Andrea Vergara* MEMS lab, Tohoku University
  - ◇ Investigation of an innovative film separation technology by applying nanosecond laser inside silicon (2D stealth dicing), then shear force was applied to finish the separation; the shear stress was as low as 20 MPa.
  - ◇ Experienced in cleanroom workflows and equipment operation, including: Mask design/fabrication, Photolithography, DRIE, PVD/CVD, Dicing, Laser systems, and Optical/SEM/Infrared microscopy. [More](#)
- **Ultrasonic vibration-assisted scratch testing platform: design and study** 2022.9-2024.4  
*Undergraduate research program advised by Prof. Hu Huang* Huang lab, Jilin University
  - ◇ Platform designed and numerical verification: Reasonable structure to ensure the transmission of ultrasonic vibration; The resonant frequency of the system is matched with the frequency of the ultrasonic transducer.
  - ◇ National Undergraduate Training Program for Innovation and Entrepreneurship(NCSEITP), **National Excellent Conclusion**, securing research funding of 10,000CNY. [More](#)

## Academic achievement

- A paper under review for the conference extended special issue: **Yao, Y.**, Vergara, A., Tang, Z. & Tanaka, S. Feasibility study of layer separation using 2D patterned internal laser damage in silicon. *Japanese Journal of Applied Physics* [Manuscript](#)
- **Oral presentation** on the 37th International Microprocesses and Nanotechnology Conference (MNC 2024), Kyoto: The Japan Society of Applied Physics, Nov. 2024, 15D-2-3. [Slide](#) [Abstract](#)
- Journal paper published: Huang, Y.; Wu, H.; **Yao, Y.**; Zhao, H.; Huang, H. An Ultrasonic Vibration Scratch Tester for Studying the Scratch Characteristics of Materials under Ultrasonic Vibration Contact Status. *Actuators* 2024, 13, 262. <https://doi.org/10.3390/act13070262>
- Utility Model Patent published: H. Huang, **Y. Yao**, Y. Huang, and H. Wu, “An ultrasonic vibration device for vibration-assisted scratch testing,” Chinese Patent CN 220649966U, Mar. 22, 2024. [Patent](#)

## Skills

- **Languages:** Native Mandarin; Fluent English including IELTS: 7.0 (6.5), CET4: 622, CET6: 559, GRE: 320; Basic Japanese
- **Professional Software:** Proficient:Solidworks, Autocad; Intermediate: Catia; Ansys, Abaqus, Recurdyn; Matlab Simulink, Origin
- **Basic Programming Skills:** Python, Matlab, C#, L<sup>A</sup>T<sub>E</sub>X

## Awards and Honors

- **National second prize-** *National University Students' Advanced Drawing Technology and Product Information Modeling Innovation Competition*  
**Content:** Advanced Engineering drawing and proficient in CAD software [More](#) 2022.8
- **Provincial first prize -** *China College Students Engineering Practice and Innovation Competition*  
**Content:** Designed and fabricated an auto-turning mini-car prototype [More](#) 2023.11
- **Exchange student scholarship** - *Japan Student Services Organization* 2023.10-2024.8
- **First-class scholarship; Excellent student** - *Jilin University* 2023.11/ 2022.11
- **Excellent student leader** - *School of Mechanical and Aerospace Engineering, Jilin University* 2022.11